





Docket No:

Examiner:

Art Unit:

TI-29012

E. Ortiz

2815



## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Kim, et al.

Serial No:

09/574,653

Conf. No:

8503

Filed:

05/18/2000

For:

A TUNABLE SIDEWALL SPACER PROCESS FOR CMOS INTEGRATED CIRCUITS

## LETTER TO OFFICIAL DRAFTSPERSON

Assistant Commissioner For Patents Washington, DC 20231

Attention: Official Draftsperson

MAILING CERTIFICATE UNDER 37 C.F.R. §1.8(a)

I hereby certify that the above correspondence is being deposited with the U.S. Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, DC 20231 on 10-26-01

Dear Sir:

Transmitted herewith for filing is one page of formal drawings for the above identified application. Charge any necessary fees to the deposit account of Texas Instruments Incorporated, Account No. 20-0668.

Respectfully submitted,

Peter K. McLarty Agent for Applicants Reg. No. 44,923

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